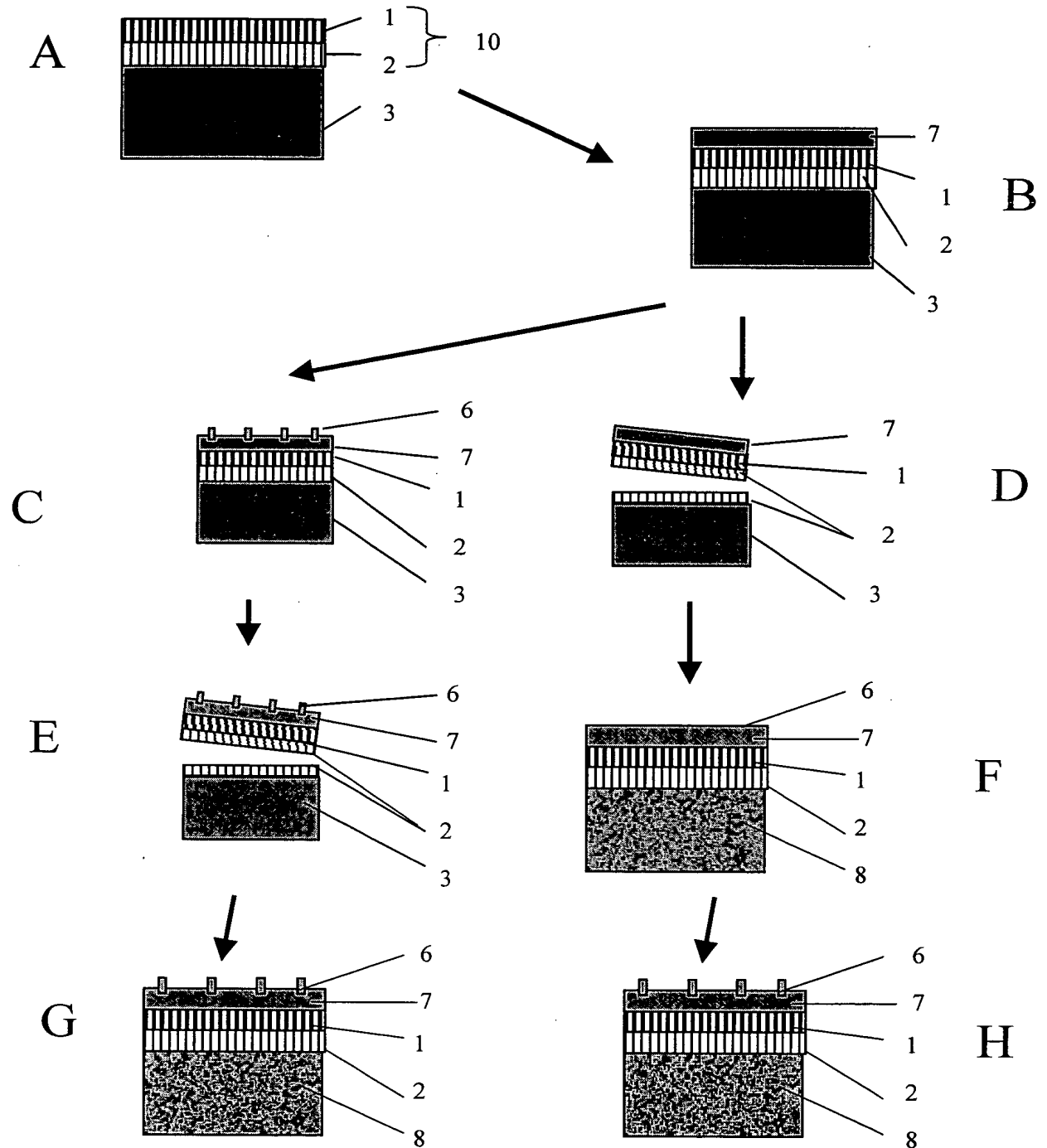


METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
SOLAR CELLS OR SILICON-ON-INSULATOR (SOI) APPLICATIONS

Solanki, et al.

Appl. No.: Unknown Atty Docket: IMEC292.001AUS



PRIOR ART

Fig. 1

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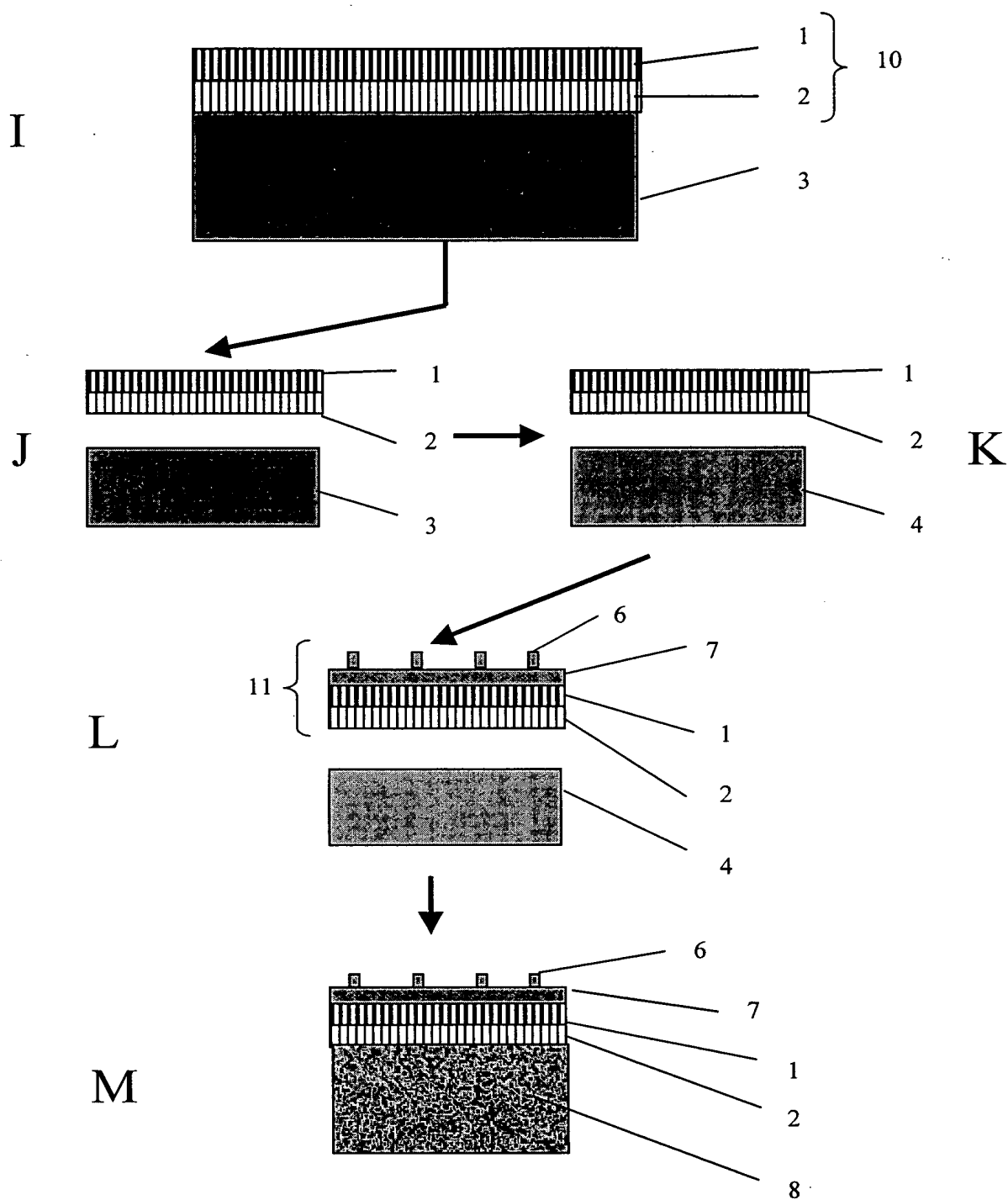


Fig. 2

METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
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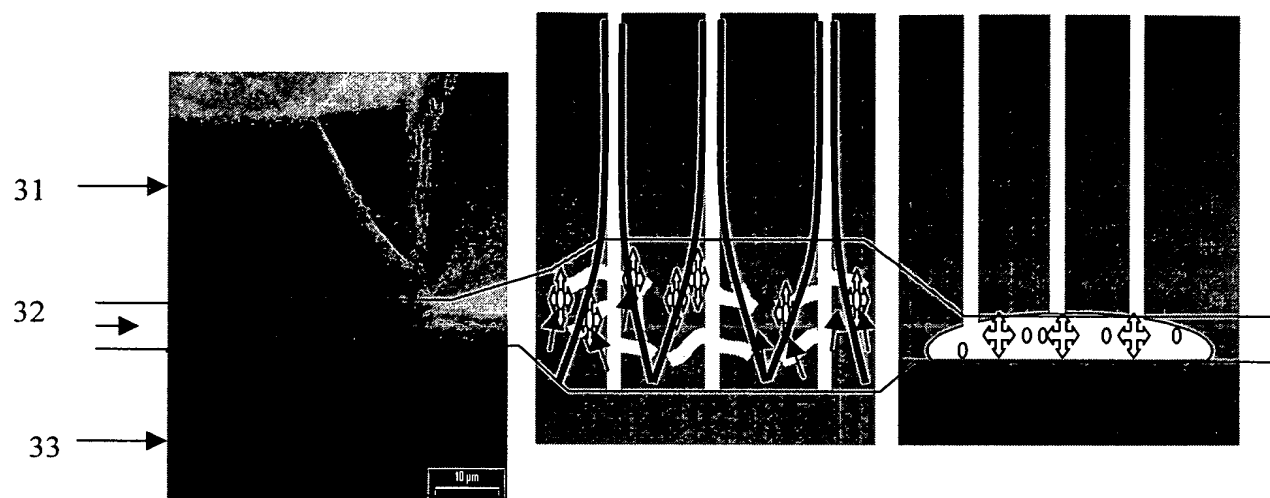


Fig. 3

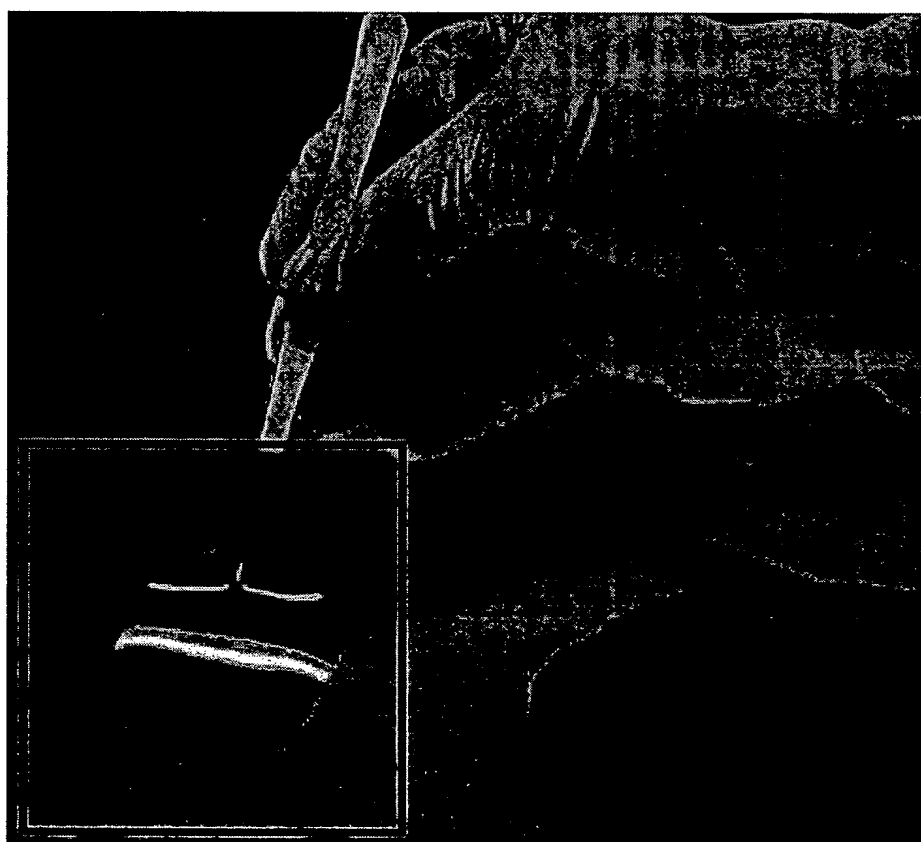
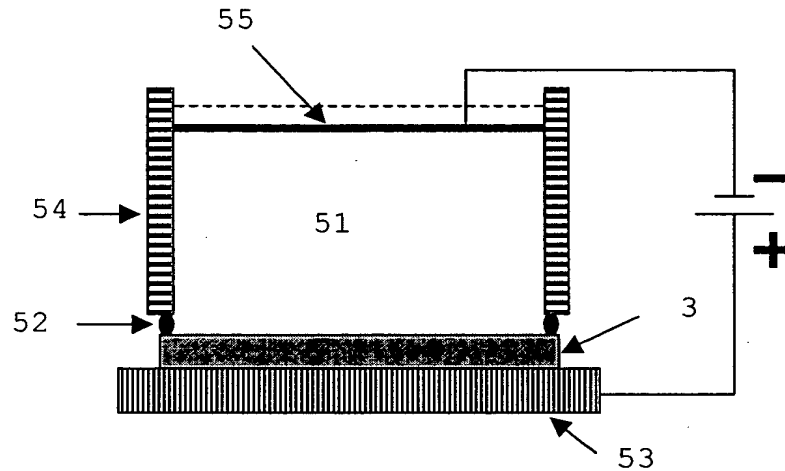


Fig. 4



PRIOR ART

Fig. 5

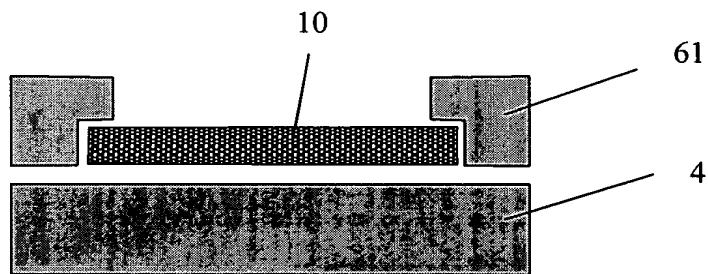


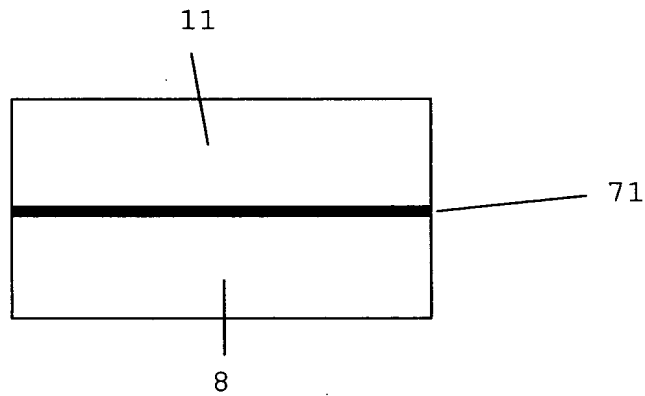
Fig. 6

*METHOD FOR MAKING THIN FILM DEVICES INTENDED FOR  
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**Fig. 7**